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AMENDMENT

(Amendment under the provision of Law Section 11)

To: Commissioner of the Patent Office

1. Identification of the International Application

PCT/JP2005/05183

2. Applicant

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4. Item to be Amended

Specification and Claims

5. Subject Matter of Amendment

- (1) At line 22, page 5 of the specification, delete "elements)" and insert -- elements), which has a film thickness of 0.2 to 400 μm , --.
- (2) At line 23, page 5 of the specification, insert -- on a substrate -- after "film".
- (3) In page 6 of the specification, delete line 7 to line 10.
- (4) At line 13, page 6 of the specification, delete "any one of".
- (5) At line 13, page 6 of the specification, delete "items (1) to (3)" and insert -- item (1) or (2) --.
- (6) At line 4, Claim 1, delete "elements)" and insert -- elements), which has a film thickness of 0.2 to 400 μm , --.
- (7) At line 5, Claim 1, insert -- on a base material -- after "film".
- (8) Cancel Claim 3 now on file.
- (9) At line 2, Claim 4, delete "any one of Claims 1 to 3" and insert -- Claim 1 or 2 --.

6. List of Attached Documents

- (1) Pages 5 and 6 of the specification and Claims